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Bib Data Sheet

**CONFIRMATION NO. 1134** 

SERIAL NUMBE 10/524,525	FILING OR 371(c) DATE 08/18/2005 RULE	<b>CLASS</b> 216	GROU	GROUP ART UNIT 1763		ATTORNEY DOCKET NO. BEET-09	
APPLICANTS Martin Hausner, Wiesbaden, GERMANY;  *** CONTINUING DATA ******************* This application is a 371 of PCT/EP03/09052 08/14/2003  *** FOREIGN APPLICATIONS ************************************							
Foreign Priority claimed 35 USC 119 (a-d) condimet Verified and Acknowledged ADDRESS	state of Country GERMAN	/ DRAV	VING	TOTAL CLAIMS 23		INDEPENDENT CLAIMS 2	
26875  TITLE  Method for selectively removing material from the surface of a substrate, masking material for a wafer, and wafer with masking material							
RECEIVED No	EES: Authority has been given in Paper  D to charge/credit DEPOSIT ACCOUNT  D for following:			All Fees  1.16 Fees (Filing)  1.17 Fees (Processing Ext. of time)  1.18 Fees (Issue)  Other  Credit			